

DOCKET NO: 245156US3CIP



"RESPONSE UNDER 37 CFR 1.116-
EXPEDITED PROCEDURE EXAMINING
GROUP 1763"

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

TSUTOMU OKABE, ET AL. : EXAMINER: MOORE, K.

SERIAL NO: 10/706,915 :

FILED: NOVEMBER 14, 2003 : GROUP ART UNIT: 1763

FOR: WAFER PROCESSING
APPARATUS HAVING DUST PROOF
FUNCTION :

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated November 16, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

PLEASE ENTER 0103/06 YK